

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|--|---|------------------|---------|------------------|
| L6 | 56 | (rotat\$5 with (substrate or wafer)) and sputter\$3 and (target with offset with (wafer or substrate)) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/07 08:02 |